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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Inventor(s): Bian et al.

Serial No.: 10/664,722

Filing Date: 9/17/2003

Title: POLISHING COMPOSITION FOR SEMICONDUCTOR WAFERS

Attorney Docket No.: 03019US

Examiner:

D. Owens

Group Art Unit:

2811

Commissioner for Patents
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Respectfully submitted,

Bian et al.

By

Blake T. Biederman

Attorney for Applicant(s)

Reg. No.: 34,124

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Complete if Known

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First Named Inventor	Bian et al.
Art Unit	2811
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Attorney Docket Number	03019US

Sheet	1	of	1
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Examiner Signature		Date Considered	
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